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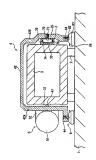
(54) 【発明の名称】 真直度測定装置

(57)【要約】

【課題】被測定物の鉛直面に対して水平方向の真直度を 安定して測定することができる真直度測定装置を提供す ること。

【解決手段】直定規3の被測定面31延長方向に沿って 移動可能に設けられ被測定面31に接触する接触子41 を有するスライダ4と、スライダ4の移動方向に反射面 を向けてスライダ4に取り付けられた反射鏡5と、スラ イダ4の移動方向から反射鏡5に向けて光を射出し、反 射鏡5からの反射光を基に被測定面31の真直度を測定 するオートコリメータと、スライダ4の接触子41が被 測定面31に一定の圧力で接するようにスライダ4を付 勢する付勢手段7と、スライダ4の接触子41が被測定 面31に接した状態を保持しつつスライダ4を被測定面 31の延長方向に沿って移動可能に支持する支持手段8 とを備えている。





【特許請求の範囲】

(請求項1)

定盤上に総置された状態において、前記定盤上面に対して略直交する鉛直面でかつ前記 定盤上面に沿って略平行に伸びる被測定面を有する被測定物の真直度を測定する真直度測 定装置であって、

前記被測定物の被測定面延長方向に沿って移動可能に設けられ前記被測定面に接触する接触子を有するスライダと

前記スライダの移動方向に反射面を向けて前記スライダに取り付けられた反射鏡と、

前記スライダの移動方向から前記反射鏡に向けて光を射出し、前記反射鏡からの反射光 を基に前記被測定面の真直度を測定するオートコリメータと、

前記スライグの接触子が前記被測定面に一定の圧力で接するように前記スライダを付勢 する付勢手段と、

前記スライダの接触子が朝記被制定面に接した状態を保持しつつ前記スライダを被測定 加延長方向に沿って移動可能に支持する支持手段とを備えていることを特徴とする真直度 測定装置。

【請求項2】

請求項1に記載の真直度測定装置において、

前記スライダは、被測定物の両側面に沿う一対の側部片および被測定物の上面に沿いか つ前記一対の側部片間を連結する上部片を有する形状に形成され。

前記一方の順部片に前記接触子が形成されているとともに、前記他方の側部片の前記接 触子と対向する位置に前記付勢手段が設けられていることを特徴とする真直度測定装置。 【請求項3】

請求項2に記載の真直度測定装置において、

前記付勢手段は、前記被測定物の前記被測定面とは反対側面にエアーを吹き出すエアー 欧出手段によって機成されていることを特徴とする真直度測定装置。

【請求項4】

請求項1~請求項3のいずれかに記載の真直度測定装置において、

前記支持手段は、前記定盤上面に対して前記スライダル所定高さ位置に保持されるよう に、前記スライダの下端部と前記定盤との間に設けられていることを特徴とする真直度測 完全置

【請求項5】

請求項4に記載の真直度測定装置において、

前記支持手段は、前記定盤上面にエアーを吹き出すエアー吹出手段によって構成されていることを特徴とする真直度測定装置。

【発明の詳細な説明】

【技術分野】

[0001]

本発明は、真直度測定装置に関する。

【背景技術】

【70002】

直定規は、測定面が水平および鉛直の2姿勢にて用いられ、水平面内および鉛直面内の 真直度基準として、機械加工されたワークの仕上げ精度や、工作機械等の幾何運動精度の 確認に用いられている。

その際、直定風の測定面が水平姿勢の場合と鉛直姿勢の場合とで漸定面の真直度が異な なため、より高特度に厳密な基準として用いるには、それぞれの姿勢ごとに真直度を値付 けする必要がある。

[0003]

従来、測定面が水平姿勢の場合。図4に示す測定法によって真直度が測定されている。 定盤91上にスペーサ92を介して直定規93を載置し、この直定規93の上面側にある 測定面(つまり被測定面94)と接触する2つの接触子95を有するスライダ96を、被 測定面94に沿って図4の紙面と直交する方向へ移動可能に設ける。スライダ96上に収り付けられて反射鏡97と対向する位置に配置されたオートコリメータ(図示信略)から 反射鏡97に対して検出光を射出し、反射鏡97からの反射光を基に被測定面94の真直度を測定する。

この測定法の場合、被測定面94の上にスライダ96を移動可能に載置した構成のため、 スライダ96の自重によって接触子95が被測定面94に一定圧で押し付けられるため 安定した測定を行うことができる。

[0004]

測定面が鉛直姿勢の場合、図5に示す測定法によって真直度が測定されている。スライ グ96の接触子り5を直定担93の結配測定面(つまり被測定面94)に当接させ、この 状態でスライグ96を被測定面94に沿って移動させながら、前途と同様な方法によって 被測定面940率直度を測定する。

この測定法の場合、スライグ96を直定規93の被測定面94に押し付けながら測定し なければならないため、被測定面94と接触子95との接触圧が押し付け力によって変動 しやすく、無管理状態であるため、安定した測定を行うことが困難であった。 [0005]

ところで、鉛直方向に設けた測定穴の真直度を測定するための装置として、縦型真直度 測定装置が提案されている(例えば、特許文献1)。

この特許文献 1 に記載の整體では、上方からワイヤによって吊り下げられたミラー付き 測定時を、クイル穴よりもやや小径の円筒形状で、ミラー付き測定院を挿入する部分が磨 コ学状に欠けているガイドバと一緒にクイル穴に挿入し、上方からオートコリメータによ を検出先をミラー付き測定簿に入りにつけ出し、ミラーからの反射光を検出しつ、ミラー 付き測定簿を入りれた写の物理が皿 上を昇降させて真直度を測定する。この際、ミラー付き測定簿を被測定面に密着させるために、ガイドバに備え付けられた押圧具に、クイル穴 における後測定面に宏着のの機能を押圧させ、それによってガイドバとミラー付き測定り と参加速に面面に反対側の内壁を押圧させ、それによってガイドバとミラー付き測定り と参加速に面面に付着きせるという手段ととっている。

[0006]

【特許文献1】実開平5-66512号公報

【発明の開示】

【発明が解決しようとする課題】

f 00071

しかしながら、このような特許文献1では、定盤に対して鉛直方向に被測定面を有する 被測定物に対して、被測定物の鉛直方向の真直度は測定できるが、鉛直方向と直行する方 向の真直度の測定は不可能である。

[0008]

本発明の目的は、被測定物の鉛直面に対して水平方向の真直度を安定して測定することができる真直度測定装置を提供することである。

【課題を解決するための手段】

[0009]

本発明の真直度測定装置は、定盤上に載置された状態において、前記定盤上面に対して 略直交する鉛直面でか一部記定盤上面に沿って略平行に伸びる被測定面を有する後期定物 の真直度を測定する真直疾測定装置であって、前記被測定物を機能近面延長方向に沿って 移動可能に設計られ前記拠測定面に接触する接触子を有するスライダと、前記スライダの 移動方向に反射面を向けて前記スライダに取り付けられた反射鏡と、前記スライダの移動 方向から前記反射鏡に向けて光を射出し、前記反射鏡からの反射光を元に前記被源定面 方面度を測定するオートコリメータと、前記スライダの接触子が前記被距面 方面度を測定するオートコリメータと、前記スライダの接触子が前記被運直に一定の圧 力で接するように前記スライダを付勢する付勢手段と、前記スライダの接触子が前記被測 定面に接した状態を保持しつつ前記スライダを被測定面極長方向に沿って移動可能に支持 する支持手段とを備えていることを特徴とする

[0010]

このような構成において、スライダを被測定物の被測定面に沿って移動、つまり、定盤 に対して水平方向へ移動させる。各移動位置において、オートコリメータから検出光を反 射鏡に向けて射出すると、その光は反射鏡によって反射され、オートコリメータに受光さ れるから、その反射者を基に、被測定地の終測定面の返面度を測定することができる。

本発明では、付勢手段によって、スライダの接触子が機制定面に一定の圧力で整するようにスライダが付勢されているから、スライダの接触子と被測定面との接点に常に一定の圧力がかかった状態でスライダを被測に知り放測定面に沿って移動させることができる。 したがって、被測定面が定盤上面に対して略直交する結直面であっても、スライダの接触 子と被測定面との接点に常に一定の圧力がかかった状態で測定できるから、その被測定面の水平方向の真直度を安定して高階に一定で多る。

しかも、支持手段によって、スライダの接触子が接腕定面に接した状態に保持された状 態で、スライダが接測定面延長方向に沿って移動可能に支持されているから、付勢手段に よる付勢力を大きくしなくてもよい、つまり、スライダの接触子が接測定面の所望位置に 接した状態を保持するために、スライダの接触子と被測定面との接点圧力を大きくしなく てもよいから、この点からも、被測定面の水平方向の真直度を安定して高精度に測定でき る。

[0011]

本発明の真直度測定装置では、被測定物の両側面に沿う一対の側部片および被測定物の 上面に沿いかつ前記・対つ側部片間を接結する上部片を育る形状に形成され、前記一方 の側部片に前記接触子が形成されているとともに、前記他方の側部片の前記接触子と対向 する位置に前記を繰子が形成されているとともに、前記他方の側部片の前記接触子と対向 する位置に前記すけ続手段が続けられていることが経ましょい。

この発明によれば、接触子と付勢手段とが被測定物を挟んで対向位置に配置されている から、被測定物に対してスライダが回転するような力が発生することがない。よって、測 定作業中にスライダが傾いたりせず、安定して測定を行うことができる。

[0012]

本発明の真直度測定装置では、前記付勢手段は、前記被測定物の前記被測定面とは反対 側面にエアーを吹き出すエアー吹出手段によって構成されていることが好ましい。

この発明によれば、付勢手段にエアー吹出手段を用いたので、付勢手段と被測定物とは 非接触であるから、摩擦等の測定就差の要因を排除することができる上に、接触による部 材の指傷等も防ぐことができる。

[0013]

本発明の真直度測定装置では、前記支持手段は、前記定盤上面に対して前記スライダが 防定高さ位置に保持されるように、前記スライダの下端部と定盤との間に設けられている ことが好ましい。

この発明によれば、スライダの下端部と定盤との間に支持手段を備えることで、被測定 物に対して、スライダの自重がかからないようにすることができ、被測定物に負荷がかか らず、変形、損傷といった測定精度を下げる要因を排除することができる。 【6004】

本発明の真直度測定装置では、前記支持手段は、前記定盤上面にエアーを吹き出すエア - 吹出手段によって構成されていることが好ましい。

この発明によれば、支持手段をエアー吹出手段によって構成することで、定盤と支持手 段とが空気膜を介して非接触となり、スライダを移動させる際に定盤と支持手段との間で 摩据を生まず、測定精度を向しませることができる。

【発明を実施するための最良の形態】

[0015]

以下、本発明の実施形態を図面に基づいて説明する。

図1~図3には被測定物である直定規3の真直度を測定する真直度測定装置が示されている。

直定規3は、定盤1上にスペーサ2を介して載置された状態において、断面が矩形枠状 で、定盤1上面に沿って略平行に伸びる中空柱形状に形成され、その断面矩形枠状の一外 側面に被測定面31を備える。被測定面31は、定盤1に対して略直交する鉛直面で、かつ定盤1上面に沿って略平行に伸びている。

[0016]

真恵定瀬定装置は、直定規3の域制定面31延長方向に治って移動可能に設けられ坡割 定面31に接触する接触子41を有するスライダ4と、スライダ4の移動方向た取射面を 向けてスライゲ4に取り付けられた反射鏡5と、スライダ4の移動方向から反射接5に向 けて光を射出し、反射鏡5からの反射接5基に被測定面31の真面度を測定するオートコ リスーク6と、スライダ4の接触子41が被測定面31に一定の下で繋をするようラ イグ4を付勢する付勢手段7と、スライダ4の接触子41が被測定面31に接した状態を 保持しつスライダ4を被測定面31の延長方向に治って移動可能に支持する支持手段8 を確成ている。

[0017]

スライゲ4は、直定期3の両側面に沿う一材の側部片42A、42Bと、直定期の上面 に沿いかつ一分の側部片42A、42B間を連結する上部片43と、側端片42Aの端落 から外側へ直角にかつ定盤1と平行に折り曲げられた底部片44とを備えている、側部片 42Aの向面側には、半球状の2つの複種子41が被測定面31の延長方向に一定間隔離 れて設けられている。

[0018]

反射鏡5は、鏡面部を有する鏡51と、鏡51をスライダ4に取り付けるための取り付け部52とを備えている。鏡51は、側部片42Aの外面側において、2つの接触子41の略中間位置に取り付けられている。

[0019]

オートコリメータ6は、綾51と対向する位置に配置され、綾51に向けて出力部(図 示省略)から検出光を射出し、綾51からの反射光を検出部(図示省略)で受光し、被測 定面31の真直度を求める。

[0020]

付勢手段7は、側部片42Bに螺合された調整ねじ71と、調整ねじ71の先端に設けられた採開制度72と、調整ねじ71に球間制度72を介して弱動可能に取り付けられた付勢用エアペアリング73は、シリンダ74と、このシリンダ74にピストンリング76を介して摺動可能に収納されたピエストン75と準備之ている。シリンダ74とピストンフラとの間に形域されたチャンバ77には、圧縮空気が溜められているとともに、シリンダ74の正独3との対向画には空気鳴出孔(図示省略)が形成されている。これにより、チャンバ77内の圧縮空気が空気鳴出孔から直定規3に向けて噴出され、直定規3との間に空気繋が形成されている。

【0021】

支持手段をは、側部サ42Bの定盤1との対向面に1つ、底部片44の定盤1との対向面に2つ設けられている。これらの支持手段8は、側部片42Bおよび底部片44に場合された剛隆も181の先端に設けられた球面軸要62と、測隆おし81の朱端に設けられた球面軸要62と、測隆おし81に球面軸要62を介して取り付けられた支持用エアベアリング83とを備える。支持用エアベアリング83は、内部に圧縮空気を溜めておくためのチャンパ(図示音略)が形成されているとともに、実施1との対向面に空気喘出れ(図示音略)が飛れれている。ナンバ、は徐奈礼84から空気が取り込まれている。これにより、チャンバ内の圧縮空気が変変強出孔から定盤1に向けて噴出され、定盤1との間に空気機が形成されている。

[0022]

このような構成からなる真貞実測定業器は、オートコリスータ6が疑う1と対向する位置から続う1に向けて検出光を射出し、続51に反射して戻ってきた反射光を検出する。 この状態で、直定期3に対して2つの接触子4と後調定面31に接触させたままスライゲイをスタイドさせ、スライドに伴う反射光の傾斜から真直度の測定を行う。 (700231)

このような本実施形態によれば、次の効果を奏することができる。

- (1) 付勢手段7によって、スライダ4の接触子41が被測定面31に一定の圧力で接方 るようにスライダ4が付勢されているから、スライダ4の接触子41と被測定面31との 接点に常に一定の圧力がかかった状態でスライダ4を直定型3つ被測定面31に沿って移 動させることができる。したがって、検測定面31が定盤1上面に対して略直交する鉛面 面であっても、スライダ4の接触子41と被測定面31との模点に常に一定の圧力がかかった状態で測定できるから、その被測定面31の水平方向の真直度を安定して高精度に測定できる。 [0024]
- (2) 支持手段8によって、スライダムの接触子4 1 が被照定面 3 1 に掲した状態に保持 された状態で、スライダ4 が被測定面 3 1 延長方向に沿って移動可能に支持されているか ら、特勢手段でによる付勢力を失さくしなくでもよい。つまり、スライダ4 の接触子4 1 が被測定面 3 1 2 が検点圧力を大きくしなくでもよいから、被測定面 3 1 の水平方向の真直度 を変生して高極度に測定である。

[0025]

- (3)接触子41と付勢手段7とが電定規3を挟んで対向位置に配置されているから、直 定規3に対してスライダ4が何転するような力が発生することがない。よって、測定作業 中にスライダ4が傾いたりせず、安定して測定を行うことができる。 【0026】
- (4)付勢用エアペアリング73と直定規3とは非接触であるから、摩擦等の測定誤差の 嬰因を排除することができる上に、接触による部材の損傷等も防ぐことができる。 【0027】
- (5)スライダ4の定盤1と対向する面に支持手段8を備えることで、直定規3に対して スライダ4の自重がかからないようにすることができ、直定規3に負荷がかからず、変形 福傷といった測定競修を下げる例知を排除することができる。
- (6)支持用エアペアリング83を用いることで、定盤1と支持用エアペアリング83と が空気膜を介して非接触となり、スライダ4を移動させる際に定盤1と支持手段8との間 で摩擦を生まず、測定精度を向上させることができる。

[0028]

(7)スライダ4の定盤1と対向する面に調整ねじ81を備えることで、接触子41と被測定面31との高さを合わせることができる。

[0029]

なお、本発明は前述の実施形態に限定されるものではなく、本発明の目的を達成できる 範囲での変形、改良等は本発明に含まれるものである。

例えば、本実施形態において、反射鏡5は、側部片42Aの外周部に取り付けられてい るが、オートコリメータ6と対向する位置で検出光を反射することができれば、スライダ 4のどの位置に取り付けても構わない。

また、付勢手段7として付勢用エアベアリング73を使用しているが、代わりにばね等を使用して付勢しても構わない。

[0030]

また、付勢手段では、付勢用エアペアリングア3が1つ設けられているが、接触子41 を被測定面31期に付勢させることができれば、例えば、2つ、3つ等といった数の付勢 用エアペアリングア3が設けられていても構かない。

また、接触子41は、2箇所に計2つ設けられているが、例えば1本の棒形状で被測定 面31と接触するものでも構わないし、3つ以上で被測定面31と接触するものでも構わ ない。

[0031]

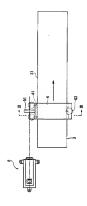
また、スライダ4は、直定規3の形状に合わせて略コ字形状であるが、被測定物の形状 に合わせて、例えば、略円形状や、略三角形状等であっても構わない。

また、支持手段8は、支持用エアベアリング83を備えているが、代わりに、底部片4

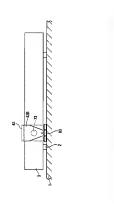
```
4および側部片42Bに定盤1上面を転動する車輪やコロ、ローラ等を設けてもよい。
また、支持手段8は、定盤1と側部片42Bおよび底部片44とが対向する面に設けら
れているが、この位置でなくとも、例えば、直定規3の上面と対向する上部片43にエア
ベアリングやローラ、車輪などを設けても構わない。
【産業上の利用可能性】
[0032]
本発明は、直定規やゲージ、または加工処理されたワーク等の真直度を測定する形状測
定器などに利用することができる。
【図面の簡単な説明】
[0033]
【図1】本発明の実施形態を示す全体図である。
【図2】本発明の実施形態を示す側面図である。
【図3】図1におけるIII-III線断面図である。
【図4】従来技術の測定法(水平物の測定法)を示す図である。
【図5】従来技術の測定法(鉛直面の測定法)を示す図である。
【符号の説明】
[0034]
 1…定線
 2…スペーサ
 3…直定規
 4…スライダ
  5…反射鏡
 6…オートコリメータ
 7…付勢手段
 8…专持手段
 31…被測定面
41…接触子
42A…側部片
42B…側部片
43…上部片
```

73…付勢用エアベアリング 83…支持用エアベアリング

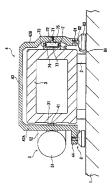
【図1】



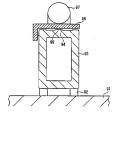
[図2]



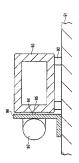
【図3】



【図4】



【図5】



Searching PAJ Page 1 of 1

PATENT ABSTRACTS OF JAPAN

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(21)Application number: 2003-405776 (71)Applicant: MITSUTOYO CORP

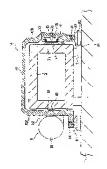
(22)Date of filing: 04.12.2003 (72)Inventor: SAKAI HISAYOSHI

(54) MEASURING APPARATUS FOR PERPENDICULARITY

(57)Abstract:

PROBLEM TO BE SOLVED: To provide a measuring apparatus for perpendicularity which can measure stably perpendicularity of the horizontal direction against the vertical plane of measured object.

SOLUTION: The measuring apparatus for perpendicularity is equipped with a sliding block 4 with a contact shoe 41 in contact with the measured plane 31, which is settled movably along an extended direction of the measured plane 31 of a straightedge 3, a reflecting mirror 5 installed on the sliding block 4 aiming a reflecting surface at the moving direction of the sliding block 4, an autocollimator measuring perpendicularity of the measured plane 31 based on reflected light from the reflecting mirror 5 that is emitted from moving direction of



the sliding block 4 into the reflecting mirror 5, an energizing unit 7 energizing the sliding block 4 so as to force the contact shoe 41 of the sliding block 4 to come into contact with the measured plane 31 at a constant pressure, and a supporting unit 8 supporting the sliding block 4 to be movable along the extended direction of the measured plane 31, keeping the contact condition between the contact shoe 41 of the sliding block 41 and the measured plane 31.

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CLAIMS

[Claim(s)]

[Claim 1]

In the state where it was laid on a surface plate, it is a straightness measuring apparatus which measures a straightness of a device under test which has a measured plane which is a vertical plane which abbreviated-intersects perpendicularly to said top face of surface plate, and is extended to abbreviated parallel along said top face of surface plate.

A slider which has contact which is provided movable along a measured plane extending direction of said device under test, and contacts said measured plane.

A reflector which turned a reflector in the move direction of said slider, and was attached to said slider.

An autocollimator which ejects [of said slider] light from movement towards said reflector, and measures a straightness of said measured plane based on catoptric light from said reflector, An energizing means which energizes said slider so that contact of said slider may touch said

A straightness measuring apparatus provided with a support means contact of said slider supports said slider movable along a measured plane extending direction holding the state where said measured plane was touched.

[Claim 2]

In the straightness measuring apparatus according to claim 1,

measured plane by a fixed pressure.

Said slider is formed in shape which has a top piece which connects between a piece of a flank of said couple over a piece of a flank of a couple and the upper surface of a device under test in alignment with both side surfaces of a device under test.

A straightness measuring apparatus while said contact is formed in said one piece of a flank, wherein said energizing means is provided in said contact of a piece of a flank of said another side, and a position which counters.

[Claim 3]

In the straightness measuring apparatus according to claim 2,

A straightness measuring apparatus, wherein said energizing means is constituted by an air blow-off means which blows off air to an opposite side face with said measured plane of said device under test

[Claim 4]

In the straightness measuring apparatus according to any one of claims 1 to 3,

A straightness measuring apparatus, wherein said support means is established between a lower end part of said slider, and said surface plate so that said slider may be held to said top face of surface plate in a prescribed height position.

(Claim 5)

In the straightness measuring apparatus according to claim 4,

A straightness measuring apparatus, wherein said support means is constituted by an air blowoff means which blows off air to said top face of surface plate.

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DETAILED DESCRIPTION

[Detailed Description of the Invention]

[Field of the Invention]

[0001]

This invention relates to a straightness measuring apparatus.

[Background of the Invention]

[0002]

A measuring plane is used with two horizontal and vertical postures, and straight edge ruler is used for the check of the finishing accuracy of the machined work, and geometric movement accuracy, such as a machine tool, as a straightness standard in the level surface and a vertical plane.

Since the straightnesses of a measuring plane differ by the case where they are a case where the measuring plane of straight edge ruler is a horizontal position, and a vertical attitude, in that case, in order to use as a stricter standard to high degree of accuracy, it is necessary to make a market a straightness for every posture.

[0003]

Conventionally, when a measuring plane is a horizontal position, the straightness is measured by the measuring method shown in drawing 4. The straight edge ruler 93 is laid via the spacer 92 on the surface plate 91, and the slider 96 which has two contact 95 in contact with the measuring plane (that is, measured plane 94) in the upper surface side of this straight edge ruler 93 is formed in the direction which intersects perpendicularly with the space of drawing-4 along the measured plane 94 movable. Detection light is ejected from the reflector 97 attached on the slider 96, and the autocollimator (graphic display abbreviation) arranged at the position which counters to the reflector 97, and the straightness of the measured plane 94 is measured based on the catoptric light from the reflector 97.

Since contact 95 is forced on the measured plane 94 by prudence of the slider 96 with

constant pressure for the composition which laid the slider 96 movable on the measured plane 94 in the case of this measuring method, stable measurement can be performed.

[0004]

When a measuring plane is a vertical attitude, the straightness is measured by the measuring method shown in drawing 5. The straightness of the measured plane 94 is measured by the same method as the above-mentioned, making contact 95 of the slider 96 contact the perpendicular measuring plane (that is, measured plane 94) of the straight edge ruler 93, and moving the slider 96 along the measured plane 94 in this state.

In order to have to measure in the case of this measuring method, forcing the slider 96 on the measured plane 94 of the straight edge ruler 93, the contact pressure of the measured plane 94 and contact 95 was easily changed according to pressure, and since it was a non-controlled state, it was difficult to perform stable measurement.

[0005]

By the way, the vertical mold straightness measuring apparatus is proposed as a device for measuring the straightness of the measuring hole provided in the perpendicular direction (for example, patent documents 1).

In a device given in these patent documents 1, the measurement piece with a mirror hung from the upper part with the wire from a quill hole with the cylindrical shape of mist or a byway. The portion which inserts a measurement piece with a mirror inserting in a quill hole together with the guide bar which lacks in the approximately U shape, ejecting the detection light by an autocollimator from the upper part to a measurement piece with a mirror, and detecting the catoptric light from a mirror. You make it go up and down a measurement piece with a mirror on the measured plane in a quill hole, and a straightness is measured. Under the present circumstances, in order to stick a measurement piece with a mirror to a measured plane, the means of making the pressing tool with which the guide bar was equipped press the wall of the measured plane in a quill hole and an opposite hand, and making it energize a guide bar and a measurement piece with a mirror to the measured plane side by it are taken.

[0006]

[Patent documents 1] JP,5-66512,U

[Description of the Invention]

[Problem(s) to be Solved by the Invention]

[0007]

However, although the straightness of the perpendicular direction of a device under test can be measured in such patent documents 1 to the device under test which has a measured plane in the perpendicular direction to a surface plate, measurement of the straightness of the perpendicular direction and the direction which goes direct is impossible.

180001

The purpose of this invention is to provide the straightness measuring apparatus which is stabilized and can measure a horizontal straightness to the vertical plane of a device under test.

[Means for Solving the Problem]

[0009]

This invention is characterized by that the state where a straightness measuring apparatus of this invention was laid on a surface plate comprises:

A slider which is a straightness measuring apparatus which measures a straightness of a device under test which has a measured plane which is a vertical plane which abbreviated-intersects perpendicularly to said top face of surface plate, and is extended to abbreviated parallel along said top face of surface plate, and has contact which is provided movable along a measured plane extending direction of said device under test, and contacts said measured plane.

A reflector which turned a reflector in the move direction of said slider, and was attached to said slider.

An autocollimator which ejects [of said slider] light from movement towards said reflector, and measures a straightness of said measured plane based on catoptric light from said reflector. An energizing means which energizes said slider so that contact of said slider may touch said measured plane by a fixed pressure, and a support means contact of said slider supports said slider movable along a measured plane extending direction holding the state where said measured plane was touched.

[0010]

In such composition, a slider is horizontally moved to movement, i.e., a surface plate, along a measured plane of a device under test. In each movement zone, if detection light is turned to a reflector and ejected from an autocollimator, it is reflected by reflector, and since light is received by autocollimator, the light can measure a straightness of a measured plane of a device under test based on the catoptric light.

In this invention, since a slider is energized by energizing means so that contact of a slider may touch a measured plane by a fixed pressure, where a fixed pressure is always applied, a slider can be moved to a point of contact of contact of a slider, and a measured plane along a measured plane of a device under test by it. Therefore, since it can measure where a fixed pressure is always applied to a point of contact of contact of a slider, and a measured plane even if a measured plane is a vertical plane which abbreviated-intersects perpendicularly to a top face of surface plate, it is stabilized and a horizontal straightness of the measured plane can be measured with high precision.

And since a slider is supported by support means movable along a measured plane extending

direction in the state where it was held at the state where contact of a slider touched a measured plane, it is not necessary to enlarge energizing force by an energizing means. That is, since it is not necessary to enlarge contact pressure of contact of a slider, and a measured plane in order for contact of a slider to hold the state where a desired position of a measured plane was touched, also from this point, it is stabilized and a horizontal straightness of a measured plane can be measured with high precision.

It is formed in shape which has a top piece which connects between a piece of a flank of said couple in a straightness measuring apparatus of this invention over a piece of a flank of a couple and the upper surface of a device under test in alignment with both side surfaces of a device under test, While said contact is formed in said one piece of a flank, it is preferred that said energizing means is provided in said contact of a piece of a flank of said another side and a position which counters.

According to this invention, since contact and an energizing means are arranged on both sides of a device under test in an opposed position, power which a slider rotates to a device under test does not occur. Therefore, a slider cannot incline during measuring work but it can measure by being stabilized.

[0012]

As for said measured plane of said device under test, in a straightness measuring apparatus of this invention, it is [said energizing means] preferred to be constituted by an air blow-off means which blows off air to an opposite side face.

Since an air blow-off means was used for an energizing means according to this invention and an energizing means and a device under test are non-contact, a factor of errors of measurement, such as friction, can be eliminated, and also damage to a member by contact, etc. can be prevented.

[0013]

It is preferred that said support means is established between a lower end part of said slider and a surface plate in a straightness measuring apparatus of this invention so that said slider may be held to said top face of surface plate in a prescribed height position.

According to this invention, by having a support means between a lower end part of a slider, and a surface plate, to a device under test, prudence of a slider can be prevented from starting, and load is not applied to a device under test, but a factor which lowers the accuracy of measurement, such as modification and damage, can be eliminated.

[0014]

As for said support means, in a straightness measuring apparatus of this invention, it is preferred to be constituted by an air blow-off means which blows off air to said top face of surface plate. According to this invention, with constituting a support means by an air blow-off means, a surface plate and a support means can serve as non-contact via an air film, when moving a slider, friction cannot be induced between a surface plate and a support means, but the accuracy of measurement can be raised.

[Best Mode of Carrying Out the Invention] [0015]

Hereafter, the embodiment of this invention is described based on a drawing.

The straightness measuring apparatus which measures the straightness of the straight edge ruler 3 which is a device under test is shown in drawing 1 - drawing 3.

In the state where it was laid via the spacer 2 on the surface plate 1, a section is rectangular frame shape, and the straight edge ruler 3 is formed in the hollow column shape extended to abbreviated parallel over the surface plate 1 upper surface, and equips one lateral surface of the rectangular cross section frame shape with the measured plane 31. The measured plane 31 is a vertical plane which abbreviated-intersects perpendicularly to the surface plate 1, and is extended to abbreviated parallel over the surface plate 1 upper surface.

[0016]

A straightness measuring apparatus is provided with the following.

The slider 4 which has contact 41 which is provided movable along measured plane 31 extending direction of the straight edge ruler 3, and contacts the measured plane 31.

The reflector 5 which turned the reflector in the move direction of the slider 4, and was attached to the slider 4.

The autocollimator 6 which ejects [of the slider 4] light from movement towards the reflector 5, and measures the straightness of the measured plane 31 based on the catoptric light from the reflector 5.

The energizing means 7 which energizes the slider 4 so that contact 41 of the slider 4 may touch the measured plane 31 by a fixed pressure, and the support means 8 contact 41 of the slider 4 supports the slider 4 movable along the extending direction of the measured plane 31 holding the state where the measured plane 31 was touched.

[0017]

The slider 4 is provided with the following.

The pieces 42A and 42B of a flank of the couple in alignment with the both side surfaces of the straight edge ruler 3.

The top piece 43 which connects between the piece 42A of a flank of a couple, and 42B over the upper surface of straight edge ruler.

The piece 44 of a pars basilaris ossis occipitalis bent in parallel [with the surface plate 1] right-angled outside from the end of the piece 42A of a flank.

Two hemispherical contact 41 constant-interval-separates, and is provided in the extending direction of the measured plane 31 at the inner surface side of the piece 42A of a flank.

The reflector 5 is provided with the following.

The mirror 51 which has a mirror surface part.

The mounting part 52 for attaching the mirror 51 to the slider 4.

The mirror 51 is attached to the abbreviated mid-position of two contact 41 at the outside surface side of the piece 42A of a flank.

[0019]

[0018]

The autocollimator 6 is arranged at the mirror 51 and the position which counters, ejects detection light from an outputting part (graphic display abbreviation) towards the mirror 51, receives the catoptric light from the mirror 51 in a primary detecting element (graphic display abbreviation), and asks for the straightness of the measured plane 31.

[0020]

The energizing means 7 is provided with the following.

The adjusting screw 71 screwed in the piece 42B of a flank.

Spherical bearing 72 provided at the tip of the adjusting screw 71.

The air bearing 73 for energization attached to the adjusting screw 71 rockable via the spherical bearing 72.

The air bearing 73 for energization is provided with the following.

Cylinder 74.

The piston 75 stored by this cylinder 74 via the piston ring 76 so that sliding was possible. While compressed air is accumulated in the chamber 77 formed between the cylinder 74 and the piston 75, the air jetting hole (graphic display abbreviation) is formed in the opposed face with the straight edge ruler 3 of the cylinder 74. Thereby, the compressed air in the chamber 77 blows off from an air jetting hole towards the straight edge ruler 3, and the air film is formed between the straight edge rulers 3.

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[Field of the Invention]

[0001]

This invention relates to a straightness measuring apparatus.

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PRIOR ART

[Background of the Invention] [0002]

A measuring plane is used with two horizontal and vertical postures, and straight edge ruler is used for the check of the finishing accuracy of the machined work, and geometric movement accuracy, such as a machine tool, as a straightness standard in the level surface and a vertical plane.

Since the straightnesses of a measuring plane differ by the case where they are a case where the measuring plane of straight edge ruler is a horizontal position, and a vertical attitude, in that case, in order to use as a stricter standard to high degree of accuracy, it is necessary to make a market a straightness for every posture.

[0003]

Conventionally, when a measuring plane is a horizontal position, the straightness is measured by the measuring method shown in drawing 4. The straight edge ruler 93 is laid via the spacer 92 on the surface plate 91, and the slider 96 which has two contact 95 in contact with the measuring plane (that is, measured plane 94) in the upper surface side of this straight edge ruler 93 is formed in the direction which intersects perpendicularly with the space of drawing-4 along the measured plane 94 movable. Detection light is ejected from the reflector 97 attached on the slider 96, and the autocollimator (graphic display abbreviation) arranged at the position which counters to the reflector 97, and the straightness of the measured plane 94 is measured based on the catoptric light from the reflector 97.

Since contact 95 is forced on the measured plane 94 by prudence of the slider 96 with constant pressure for the composition which laid the slider 96 movable on the measured plane 94 in the case of this measuring method, stable measurement can be performed. [0004]

When a measuring plane is a vertical attitude, the straightness is measured by the measuring

method shown in <u>drawing 5</u>. The straightness of the measured plane 94 is measured by the same method as the above-mentioned, making contact 95 of the slider 96 contact the perpendicular measuring plane (that is, measured plane 94) of the straight edge ruler 93, and moving the slider 96 along the measured plane 94 in this state.

In order to have to measure in the case of this measuring method, forcing the slider 96 on the measured plane 94 of the straight edge ruler 93, the contact pressure of the measured plane 94 and contact 95 was easily changed according to pressure, and since it was a non-controlled state, it was difficult to perform stable measurement.

[0005]

By the way, the vertical mold straightness measuring apparatus is proposed as a device for measuring the straightness of the measuring hole provided in the perpendicular direction (for example, patent documents 1).

In a device given in these patent documents 1, the measurement piece with a mirror hung from the upper part with the wire from a quill hole with the cylindrical shape of mist or a byway. The portion which inserts a measurement piece with a mirror inserting in a quill hole together with the guide bar which lacks in the approximately U shape, ejecting the detection light by an autocollimator from the upper part to a measurement piece with a mirror, and detecting the catoptric light from a mirror. You make it go up and down a measurement piece with a mirror on the measured plane in a quill hole, and a straightness is measured. Under the present circumstances, in order to stick a measurement piece with a mirror to a measured plane, the means of making the pressing tool with which the guide bar was equipped press the wall of the measured plane in a quill hole and an opposite hand, and making it energize a guide bar and a measurement piece with a mirror to the measured plane side by it are taken.

[0006] [Patent documents 1] JP,5-66512,U

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TECHNICAL PROBLEM

[Problem(s) to be Solved by the Invention] [0007]

However, although the straightness of the perpendicular direction of a device under test can be measured in such patent documents 1 to the device under test which has a measured plane in the perpendicular direction to a surface plate, measurement of the straightness of the perpendicular direction and the direction which goes direct is impossible. [0008]

The purpose of this invention is to provide the straightness measuring apparatus which is stabilized and can measure a horizontal straightness to the vertical plane of a device under test.

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MEANS

[Means for Solving the Problem] [0009]

This invention is characterized by that the state where a straightness measuring apparatus of this invention was laid on a surface plate comprises:

A slider which is a straightness measuring apparatus which measures a straightness of a device under test which has a measured plane which is a vertical plane which abbreviated-intersects perpendicularly to said top face of surface plate, and is extended to abbreviated parallel along said top face of surface plate, and has contact which is provided movable along a measured plane extending direction of said device under test, and contacts said measured plane.

A reflector which turned a reflector in the move direction of said slider, and was attached to said slider

An autocollimator which ejects [of said slider] light from movement towards said reflector, and measures a straightness of said measured plane based on catoptric light from said reflector. An energizing means which energizes said slider so that contact of said slider may touch said measured plane by a fixed pressure, and a support means contact of said slider supports said slider movable along a measured plane extending direction holding the state where said measured plane was touched.

[0010]

In such composition, a slider is horizontally moved to movement, i.e., a surface plate, along a measured plane of a device under test. In each movement zone, if detection light is turned to a reflector and ejected from an autocollimator, it is reflected by reflector, and since light is received by autocollimator, the light can measure a straightness of a measured plane of a device under test based on the catoptic light.

In this invention, since a slider is energized by energizing means so that contact of a slider may touch a measured plane by a fixed pressure, where a fixed pressure is always applied, a slider can be moved to a point of contact of contact of a slider, and a measured plane along a measured plane of a device under test by it. Therefore, since it can measure where a fixed pressure is always applied to a point of contact of contact of a slider, and a measured plane even if a measured plane is a vertical plane which abbreviated-intersects perpendicularly to a top face of surface plate, it is stabilized and a horizontal straightness of the measured plane can be measured with high precision.

And since a slider is supported by support means movable along a measured plane extending direction in the state where it was held at the state where contact of a slider touched a measured plane, it is not necessary to enlarge energizing force by an energizing means. That is, since it is not necessary to enlarge contact pressure of contact of a slider, and a measured plane in order for contact of a slider to hold the state where a desired position of a measured plane was touched, also from this point, it is stabilized and a horizontal straightness of a measured plane can be measured with high precision.

[0011]

It is formed in shape which has a top piece which connects between a piece of a flank of said couple in a straightness measuring apparatus of this invention over a piece of a flank of a couple and the upper surface of a device under test in alignment with both side surfaces of a device under test, While said contact is formed in said one piece of a flank, it is preferred that said energizing means is provided in said contact of a piece of a flank of said another side and a position which counters.

According to this invention, since contact and an energizing means are arranged on both sides of a device under test in an opposed position, power which a slider rotates to a device under test does not occur. Therefore, a slider cannot incline during measuring work but it can measure by being stabilized.

[0012]

As for said measured plane of said device under test, in a straightness measuring apparatus of this invention, it is [said energizing means] preferred to be constituted by an air blow-off means which blows off air to an opposite side face.

Since an air blow-off means was used for an energizing means according to this invention and an energizing means and a device under test are non-contact, a factor of errors of measurement, such as friction, can be eliminated, and also damage to a member by contact, etc. can be prevented.

[0013]

It is preferred that said support means is established between a lower end part of said slider and a surface plate in a straightness measuring apparatus of this invention so that said slider

may be held to said top face of surface plate in a prescribed height position.

According to this invention, by having a support means between a lower end part of a slider, and a surface plate, to a device under test, prudence of a slider can be prevented from starting, and load is not applied to a device under test, but a factor which lowers the accuracy of measurement, such as modification and damage, can be eliminated.

[0014]

As for said support means, in a straightness measuring apparatus of this invention, it is preferred to be constituted by an air blow-off means which blows off air to said top face of surface plate.

According to this invention, with constituting a support means by an air blow-off means, a surface plate and a support means can serve as non-contact via an air film, when moving a slider, friction cannot be induced between a surface plate and a support means, but the accuracy of measurement can be raised.

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DESCRIPTION OF DRAWINGS

[Brief Description of the Drawings] [0033]

[Drawing 1]It is the general drawing showing the embodiment of this invention.

[Drawing 2]It is a side view showing the embodiment of this invention.

[Drawing 3]It is an III-III line sectional view in drawing 1.

[Drawing 4]It is a figure showing the measuring method (measuring method of a level thing) of conventional technology.

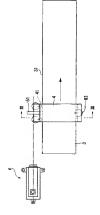
[Drawing 5]It is a figure showing the measuring method (measuring method of a vertical plane) of conventional technology.

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DRAWINGS

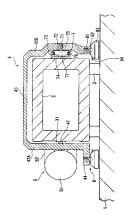
[Drawing 1]



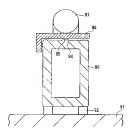
[Drawing 2]



[Drawing 3]



[Drawing 4]



[Drawing 5]

